

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Eva Tois et al.
App. No : 10/678,766
Filed : October 2, 2003
For : METHOD OF GROWING OXIDE
THIN FILMS
Examiner : Matthew Song
Art Unit : 1714
Conf No. : 1629

COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicants respectfully disagree with the Examiner's statement of reasons for allowance to the extent it implies that the Examiner made a prima facie case of obviousness. Applicants disagree that a prima facie case of obviousness was made by the Examiner with the cited references.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: September 28, 2010

By: David K. Buckingham

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